

Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)	Complete if Known	
	Application Number	10/634,174
	Filing Date	August 5, 2003
	First Named Inventor	Forbes, Leonard
	Group Art Unit	2823
	Examiner Name	Garcia, Joannie
Sheet 1 of 1	Attorney Docket No: 1303.102US1	

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EXAMINER

Joannie A. Garcia

DATE CONSIDERED

September 29, 2005

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